



Veeder-Root Sixth Ave. at Burns Crossing

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EC Declaration of Conformity

The Manufacturer declares that the products:

TLS System for Inventory Measurement and Leak Detection of Flammable Liouid Storage Tanks & Piping

Equipment Group II (1)G [Ex ia] IIA

are in compliance with the following EC directive (including all applicable amendments):

ATEX Directive 94/9/EC

the following harmonised technical standards have been applied:

EN 50014:1997+A1/A2:1999
EN 50020:2002
EN 60079-0:2006
EN 60079-11:2007
EN 60079-25:2004
Electrical Apparatus for Explosive Gas Atmospheres Intrinsic Safety
Electrical Apparatus for Explosive Gas Atmospheres General Requirements
Explosive Atmospheres – Part 11: Equipment Protection by Intrinsic Safety "I"
Electrical Apparatus for Explosive Gas Atmospheres – Part 25: I. S. Electrical Systems

EN 60079-26:2004 Construction, test and marking of group II, Category 1G Electrical Apparatus

and be produced in compliance with the model approved by the EC type- examination certificate:

DEMKO 06 ATEX 137480X

issued by the following notified body:

UL International Demko A/S P.O. Box 514 Lyskaer 8, DK-2730 Herlev, Denmark; No. 0539

and furthermore comply with the provisions of the following EC directive (including all applicable amendments):

LVD Directive 2006/93/EC, EMC Directive 2004/108/EC

the following harmonised technical standards have been applied:

EN 61010-1:2001 Safety Requirements for Electrical Equipment for Measurement, Control and Laboratory Use – Part 1

- General Requirements

EN 55024:1998+A1:2001+A2:2003 Information technology equipment. Immunity characteristics EN 55022:1998+A1:2000+A2:2003 Information technology equipment. Radio disturbances characteristics

EN 61000-3-2:2000 Limits – Section 2: Limits for harmonic current emissions EN 61000-3-3:1995+A1:2001 Limits – Section 3: Limits of voltage fluctuations and flicker

VEEDER-ROOT Inc.
Quality Assurance Manager
Harold Findley

Signatory Location: Altoona, PA USA; Date: May 8, 2009